Notice of References Cited Application/Control No. | Applicant(s)/Patent Under | Reexamination | BERTSCH ET AL. | Examiner | Ayal I Sharon | 2123 | Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	Α	US-			
	В	US-			
	Ċ	US-			
	D	US-			
	Ε	US-			
	F	US-			
	G	US-			
	н	US-			
	l	US-			
	J	US-			
	К	US-			
	L	US-			
	М	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	0					
	Р					
	Q					
	R			,		
	S					
	Т					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	Van Zant, P. Microchip Fabrication: A Practical Guide to Semiconductor Processing. ISBN 0-07-135636-3. © 2000. Chapter 15.
	v	Rajsuman, R. System-on-a-Chip: Design and Test. ISBN 1-58053-107-5. © 2000. Chapters 4 and 9-11.
	w	
	×	

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)

Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.